

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

TAKITA et al.

Serial No. 09/046,671

Group Art Unit: 2823

Filed: March 24, 1998

Examiner: Eaton, K.

For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

RESPONSE UNDER 37 CFR § 1.121

Commissioner for Patents
Washington, D.C. 20231

June 26, 2000

Sir:

In response to the Office Action mailed January 24, 2000, having been duly extended from April 24, 2000 until June 26, 2000 by the attached Petition for Extension of Time, please amend the above-identified application as set forth below.

IN THE TITLE

Please delete the originally filed title and substitute therefor:

--SEMICONDUCTOR DEVICE HAVING ELECTRICAL DIVIDED SUBSTRATE AND
METHOD FOR FABRICATING THE SEMICONDUCTOR DEVICE--.

IN THE DRAWINGS

Submitted herewith is a Request for Approval of Drawing Changes and a red-lined copy of Figure 29A depicting a correct identification of n-well 138.

IN THE CLAIMS

Please amend the claims as follows.

1. (Amended) A semiconductor device comprising:

a semiconductor substrate of a first conduction type;



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